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MS ISSUE FEE
PATENT
0020-4666P

IN THE U. S. PATENT AND TRADEMARK OFFICE

Applicants: Fumihiro KONUSHI et al. Conf.: 1396
Appln. No.: 09/492,803✓ Art Unit: 2828
Filed: January 28, 2000 Examiner: Q. P. LEUNG
For: SEMICONDUCTOR LASER DEVICE AND METHOD OF
MANUFACTURING SAME

COMMENTS ON STATEMENT OF REASONS FOR ALLOWANCE

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Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

July 21, 2004

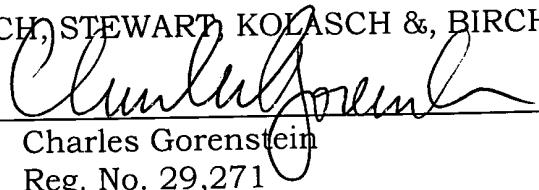
Sir:

The Examiner's statement of reasons for allowance states features not taught by prior art of record. However, it is noted that the claims stand upon their own recitations, and limitations should not be imputed to the claims based upon the statement of reasons for allowance.

If necessary, the Commissioner is hereby authorized in this, concurrent, and future replies, to charge payment or credit any overpayment to Deposit Account No. 02-2448 for any additional fees required under 37 C.F.R. §§ 1.16 or 1.17; particularly, extension of time fees.

Respectfully submitted,

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